

Positron Annihilation Study of the Semiconductor to Metal Transition in Ti_2O_3

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An increase of positron mean life is found to accompany the semiconductor-metal transition in Ti_2O_3 . This agrees well with the recent finding that the unit cell volume increases during the transition.

Positron annihilation is known to be very sensitive to various second order transitions as well as first order transitions². A change of the positron annihilation parameters during the semiconductor to metal transition in V_2O_5 has been reported in the literature³. In this note, we briefly report our findings on positron annihilation in Ti_2O_3 during its semiconductor to metal transition.

The resolution of the apparatus for the positron lifetime measurements was about $\text{FWHM} = 300 \text{ psec}^4$. The sample was obtained from Alfa Products as 99+ % pure and in powder form. The sample was sealed with a ^{22}Na source deposited on thin mica ($< 2 \text{ mg/cm}^2$) and evacuated to less than 10^{-5} torr. The measurements were made in a temperature range from room temperature to 670 K. After each measurement, which took 20 hours, the temperature was raised or lowered, and the next measurement started. Two ascending and descending series of

measurements were made. Both two exponential components and single exponential component curves were used for data reduction and analysis⁵.

The two exponential components analysis gave $\tau_1 \sim 200 \text{ psec}$ and $\tau_2 \sim 400 \text{ psec}$ with an intensity of the latter of $\sim 5\%$. Due to the closeness of the values of τ_1 and τ_2 and the small intensity I_2 , the statistical uncertainty was very high and no definite trend could be found. The result obtained from the single exponential analysis is shown in Figure 1. At room temperature and up to nearly 370 K, the values of positron meanlife τ are about 210 psec and at temperature higher than $\sim 470 \text{ K}$, τ increases to about 224 psec. The transition region covers a wide temperature range and lies within the range of the semiconductor to metal transition region reported⁶.

In general, an increase in the positron meanlife with temperature in solid media can be attributed to either the availability of more free volume within the expanding lattice⁷ or more trapping in thermal vacancies⁸, or both. Past studies^{6,9} indicated that there is a 7% decrease in the volume of the unit cell of Ti_2O_3 in the range of 390 to 470 K. A more recent, refined single crystal study¹⁰, however, shows that there is a slight increase of about 0.4% in the volume of the unit cell in the range 370–570 K as shown in Figure 2. The result of the positron annihilation measurements is consistent with the latter finding and seem to support the free volume model. It may be noted that the lifetime increases abruptly during the first-order phase transition of NH_4Cl which is accompanied by a marked increase in volume¹¹. The increase in lifetime in the case of the Ti_2O_3 transition is small and gradual since this transition is of second order⁶. More studies along these lines would throw light on the mechanism of positron annihilation in inorganic solids.

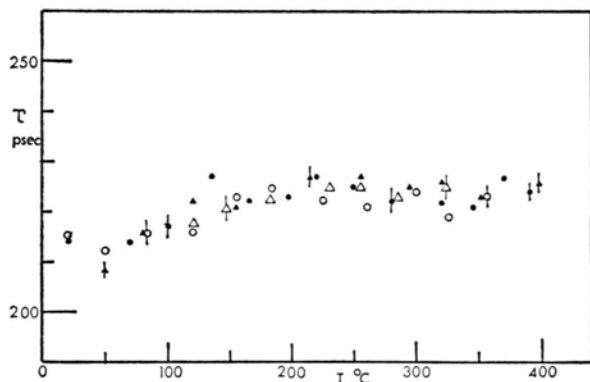


Fig. 1

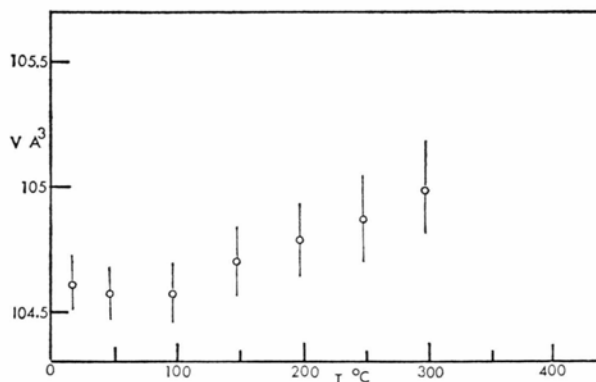


Fig. 2

- ¹ Reprints should be addressed to the author.
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